

Notice of References Cited	Application/Control No. 10/595,191		Applicant(s)/Patent Under Reexamination NAKAMURA, TADASHI	
	Examiner NICHOLAS LEE		Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0114474 a1	06-2004	Park et al.	369/030.05
*	B	US-2005/0025007 a1	02-2005	Park, Yong Cheol	369/047.22
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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